

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*In re* Application of: John Robert Lamberty *et al.*

Serial Number: 10/711,983

Group Art Unit: 2882

Filing Date: October 18, 2004

Examiner: Chih-Cheng Glen Kao

For: METHOD AND SYSTEM FOR SCATTER CORRECTION  
DURING BI-PLANE IMAGING WITH SIMULTANEOUS EXPOSURE

Attorney Docket Number: 125720 (GEMS-0169-PUS)

**CERTIFICATE OF MAILING/TRANSMISSION**

I hereby certify that this correspondence is, on the date shown below, being filed electronically with the United States Patent & Trademark Office via EFS Web.



Signature

Date: 12-18-2006

Donna Kraft

**AMENDMENT AND REQUEST FOR RECONSIDERATION**  
**(37 C.F.R. § 1.116 AND § 1.121)**

Commissioner for Patents  
Attention: Examiner Chih-Cheng Glen Kao  
Mail Stop AF  
P. O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

To better highlight the patentable differences between the above-referenced invention and prior art that is cited by Examiner in an Office Action marked "FINAL" and dated July 18, 2006, Applicants hereby submit this "Amendment and Request for Reconsideration" for their above-referenced Application pursuant to 37 C.F.R. § 1.116 and § 1.121. In submitting this Amendment, Applicants respectfully aver that the Application, as herein amended, is in a condition for allowance and notice thereof is respectfully requested. At the present time, therefore, please amend the Application as hereinafter indicated.